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# Room-temperature magnetic Heusler compound Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si with semiconducting behavior



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#### ABSTRACT

The structural, magnetic and electron-transport properties of Fe $_2$ Ti $_{0.5}$ Co $_{0.5}$ Si are investigated. It is demonstrated that rapidly quenched Fe $_2$ Ti $_{0.5}$ Co $_{0.5}$ Si ribbons crystallize in the L2 $_1$  structure, indicating a full Heusler compound, and exhibit ferromagnetism with a high Curie temperature of about 790 K. Moreover, Fe $_2$ Ti $_{0.5}$ Co $_{0.5}$ Si exhibits semiconducting behavior with a negative temperature coefficient of resistivity, a room-temperature resistivity of about 6.5 m $\Omega$  cm and a residual resistivity  $\rho_0$  of about 6.75 m $\Omega$  cm. The carrier concentration n is  $1.15 \times 10^{20}$  cm  $^{-3}$  at 5 K. The magnetic semiconducting behavior with a high Curie temperature makes this material promising for room-temperature spintronic and magnetic applications.

#### 1. Introduction

Spintronics aims to develop devices that exploit electronic spins for manipulation, storage and retrieval of data, replacing the conventional charge-based devices [1,2]. In spintronic devices, spin injection, i.e., efficient generation of a spin-polarized current, is an essential issue [3]. Half-metallic ferromagnets [4] and dilute magnetic semiconductors (DMS) [5,6], have attracted much attention because these materials, in principle, can produce completely (100%) spin-polarized currents. In addition, a high Curie temperature (Tc), i.e., well above room temperature (RT), is required for device applications, although it is elusive, particularly in certain dilute magnetic semiconductors such as (Ga, X)Y, (X = Mn, Co, Fe, Ni), (Y = As, N) [6]. In recent years, there has been an upsurge of research on new materials with these desired properties, especially the family of Heusler compounds. Many half-Heusler compounds (C1<sub>b</sub> structure) are found to be nonmagnetic semiconducting materials [7-9]. However, only a small number of full-Heusler compounds (L21 structure) are found to be semiconductors [10]. Among the rare full-Heusler semiconductors, Fe<sub>2</sub>TiSi has been calculated to be a ntype semiconducting material, with a sizeable gap (0.41 eV) and large Seebeck coefficient ( $-300 \,\mu\text{V/K}$  at room temperature) [11]. Based on the Slater-Pauling rule, Fe2TiSi (24 valence electrons) is predicted to possess a magnetic moment of 0 µ<sub>B</sub>/f.u. [12]. Accordingly, single-phase metastable Fe<sub>2</sub>TiSi has been synthesized as a paramagnetic semiconducting material with a band gap of about 0.4 eV, exhibiting an extremely weak magnetization and a Kondo-like effect at low temperature [13]. Fe<sub>2</sub>TiSn is found to be a semimetal [14,15], although also predicted to be a semiconductor [11]. On the other hand, the Heusler compound Fe<sub>2</sub>CoSi (29 valence electrons) is known as a ferromagnetic material with a quite high  $T_{\rm C}$  of 1038 K and magnetization of 4.92  $\mu_{\rm B}/f.u.$  at 5 K. DFT calculations show a zero-gap half-metallic valence-band spectrum close to the Fermi energy [16]. In order to combine the high saturation magnetization of Fe<sub>2</sub>CoSi with the semiconducting property of Fe<sub>2</sub>TiSi, it is of interest to replace half of the Ti atoms in the compound Fe<sub>2</sub>TiSi with Co atoms. In this paper, we demonstrate the synthesis of ferromagnetic semiconducting Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si (26.5 valence electrons), and the structural, magnetic and transport properties are measured and discussed.

## 2. Materials and methods

High-purity elements were made into ingots of Fe $_2$ Ti $_{0.5}$ Co $_{0.5}$ Si by arc melting in an argon atmosphere. Ingots were melted and ejected in a melt spinner from a quartz tube onto the surface of a copper wheel rotating at a speed of 25 m/s. This rapid quenching technique produced ribbon samples, about 2 mm wide and 50  $\mu$ m thick. The investigation of the crystal structures in the samples was performed using powder X-ray diffraction (XRD) in a PANalytical Empyrean diffractometer with copper K $\alpha$  radiation (wavelength of 1.5406 Å), and the confirmation of elemental compositions was done with energy-dispersive X-ray

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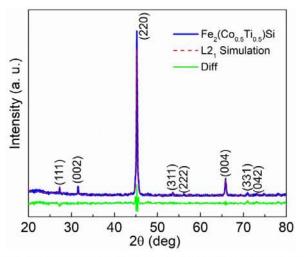


Fig. 1. Powder XRD pattern of the  $Fe_2Ti_{0.5}Co_{0.5}Si$  compound prepared by melt spinning (blue) and the pattern simulated for the  $L2_1$  structure of the  $Fe_2Ti_{0.5}Co_{0.5}Si$  compound (dash on red). (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

spectroscopy (EDX) in a FEI Nova NanoSEM450. Magnetic properties and electron-transport properties were measured with a Quantum Design VersaLab magnetometer and Physical Properties Measurement System (PPMS). In the measurement of magnetization, the applied magnetic field was parallel to the length of the ribbons, whereas the magnetoresistance and Hall measurements were done with the magnetic field perpendicular to the ribbons.

## 3. Results and discussion

## 3.1. XRD analysis

Fig. 1 shows the powder XRD pattern of Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si, which contains the fundamental (111) and (002) superlattice peaks at 27° and 32" respectively, indicating the L21 structure. In order to understand the crystalline order (B2, L21), long-range order parameters SL21 and SB2 can be used as a measure of closeness to ideal L21 and B2 structures with the equations:  $S_{B2}^2 = I_{200} \cdot I_{400}^{fullorder} / I_{400} \cdot I_{200}^{fullorder}$  and  $(S_{L21}(3 - S_{B2})/2)^2 = I_{111} \cdot I_{200}^{fullorder} / I_{220} \cdot I_{111}^{fullorder}$ , where  $I_{hkl}$  and  $I_{hkl}^{fullorder}$  are respectively the experimental diffraction intensities for the (h k l) planes and the reference intensities calculated for the fully ordered alloys. The value of S<sub>L21</sub> was calculated to be 97% based on the intensities of the corresponding peaks in the XRD pattern of the powder sample prepared with the as-quenched ribbons. In order to confirm the calculated  $S_{L21}$ , a Rietveld analysis of the XRD pattern was performed and is as shown in Fig. 1 (red dashed line). The value of S<sub>L21</sub> from the Rietveld analysis is in very good agreement with the above value, which suggests that the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si ribbons have mainly the ordered L2<sub>1</sub> structure with little disorder. L21-type structure formation also has been predicted theoretically in most of the Ti-based full Heusler compounds [17]. However, X-ray diffraction analysis confirms that the stoichiometry and the site occupancy are different in our samples compared with those Ti-based full Heusler compounds. The elemental compositions determined by EDX analysis are very close (within 5%) to the values estimated with the initial weight of the constituent elements.

#### 3.2. Magnetism

Fig. 2(a) shows isothermal magnetization M(H) curves of the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si Heusler compound measured at 5 K and 300 K. The M

(H) loops exhibit ferromagnetism with small coercivities of about 50 Oe at both 5 K and 300 K. The magnetization of the Fe $_2$ Ti $_0.5$ Co $_0.5$ Si ribbons is 480 emu/cm $^3$  (2.36  $\mu_B$ /f.u.) at 5 K and 450 emu/cm $^3$  (2.21  $\mu_B$ /f.u.) at 300 K, which is contrary to the very weak magnetism in Fe $_2$ TiSi and Fe $_2$ VAl [10,13,18–20], but lower than that of Fe $_2$ CoSi [16]. Compared with the theoretical value of 2.5  $\mu_B$ /f.u., predicted by Slater-Pauling rule [12], the magnetization is slightly lower possibly due to the minor chemical disorder. Fig. 2(b) shows the temperature dependence of the magnetization M(T) of the Fe $_2$ Ti $_0.5$ Co $_0.5$ Si compound measured under a magnetic field of 10 kOe. The Curie temperature is about 790 K, much higher than that of diluted magnetic semiconductors (Ga, X)Y, (X = Mn, Co, Fe, Ni), (Y = As, N) [6]. The partial substitution of Ti by Co produces enhanced magnetic properties in the compound.

#### 3.3. Electron transport

The temperature dependence of the longitudinal resistivity  $\rho_{xx}$  was measured between 5 K and 300 K and the magnetoresistance (MR) was measured at various temperatures with a maximum applied magnetic field of 70 kOe. As shown in Fig. 3(a), the resistivity  $\rho_{xx}$  exhibits a negative temperature coefficient, indicating semiconducting behavior in the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si compound. The residual resistivity ρ<sub>0</sub> in this material is about  $6.75 \,\mathrm{m}\Omega\,\mathrm{cm}$ , which is at least one order higher than the values in metallic Heusler compounds Fe<sub>2</sub>CoSi [16] and Co<sub>2</sub>TiSi [21] and in spin-gapless semiconducting Heusler compounds Mn<sub>2</sub>CoAl [22,23] and CoFeMnSi [24,25]. As reported for the paramagnetic semiconducting Fe<sub>2</sub>TiSi films, the band gap is about 0.4 eV and the resistivity shows a little change in a wide temperature range [13]. Compared to Fe<sub>2</sub>TiSi, Fe2Ti0.5Co0.5Si has a similar resistivity but the conductivity of this material is more complicated. The resistivity of Fe2Ti0.5Co0.5Si does not show a significant change between 5 K and 300 K possibly due to a smaller band gap than that of a usual semiconductor. It may even be close to the case of spin-gapless semiconductors that have zero band gap and nearly temperature-independent conductivities [22-24], in consideration of the magnetoresistance and carrier concentration to be discussed in the remaining of this paper. The variation in the overall temperature dependence of resistivity is similar to extrinsic to intrinsic transitions in semiconductors such as CoFeMnSi [25] and ZrSTe [26]. Moreover, at temperatures lower than 100 K, the inset shows an essentially logarithmic temperature dependence, quite similar to the temperature-dependent behavior of the Kondo effect [13,27-30]. Fig. 3(b) shows the transverse magnetoresistance of the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si compound. The low-field MR has a negative slope at all temperatures from zero field to the saturation field of magnetization and is attributed to the anisotropic magnetoresistance (AMR). After the saturation of magnetization, the change of the slope from being negative to being positive as the temperature increases is uncommon in traditional magnetic materials. However, similar phenomena are reported in various Heusler compounds such as Fe2CoSi, CoFeCrAl and the bulk spingapless semiconductor Mn<sub>2</sub>CoAl [16,23,31]. The negative MR at low temperatures under high magnetic fields is consistent with spin-dependent scattering of conduction electrons, while the positive MR at the room temperature may be attributed to the ordinary Lorentz-force mechanism. Two mechanisms of MR have different temperature dependences, thus competing with each other as the temperature increases. The MR is about 17% under a magnetic field of 70 kOe at 5 K, which is much higher than that of the Fe2CoSi compound and comparable to the MR in Fe<sub>2</sub>TiSi films and the bulk spin-gapless semiconductor Mn<sub>2</sub>CoAl [13,16,23].

Fig. 4(a) shows the Hall resistivity  $\rho_{xy}(H)$  of the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si Heusler compound measured between 5 K and 300 K. The  $\rho_{xy}(H)$  curves have a sharp increase under low magnetic fields and become smooth with a small positive slope after the saturation of magnetization. The Hall resistivity  $\rho_{xy}$  can be expressed as  $\rho_{xy}(H, T) = R_0 \cdot H + R_A \cdot M(H, T)$ , where the first term depends on the external magnetic field (ordinary Hall resistivity) and the second term

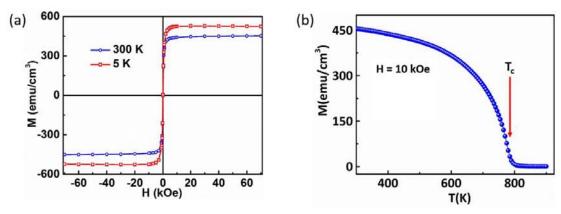


Fig. 2. (a) The magnetization M(H) of the  $Fe_2Ti_{0.5}Co_{0.5}Si$  Heusler compound at 5 K and 300 K. (b) The temperature dependence of the magnetization of  $Fe_2Ti_{0.5}Co_{0.5}Si$  at H = 10 kOe.

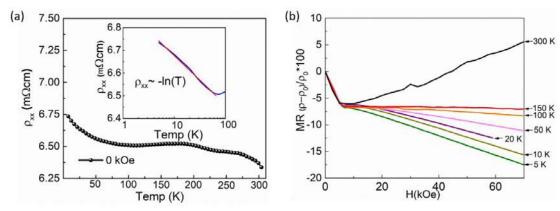


Fig. 3. (a) The longitudinal resistivity  $\rho_{xx}$  of Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si ribbons as a function of the temperature with no magnetic field applied. The inset shows the logarithmic temperature dependence of  $\rho_{xx}$  below 100 K. (b) Magnetoresistance of Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si at various temperatures.

depends on the magnetization of the film (anomalous Hall resistivity), with the coefficient  $R_0$  in the expression being the ordinary Hall coefficient and  $R_A$  being the anomalous Hall coefficients [32]. These coefficients can be determined by extrapolating the high-field portion of  $\rho_{xy}(H)$  curves to H=0, where the slope and the intercept of a line are respectively equal to  $R_0$  and  $R_AM_S$ , with  $M_S$  being the saturation magnetization. Accordingly, the carrier concentration n and the mobility  $\mu$ 

in the compound are determined with the help of  $R_0$  using the single-band model, i.e.  $R_0=1/ne$  and  $\mu=R_0(T)/\rho(T)$ . Fig. 4(b) plots the carrier concentration n and the mobility  $\mu$  as a function of the temperature (T), where the carrier concentration n may increase and the mobility  $\mu$  decrease with the increasing temperature due to the thermal excitation of electrons, and increased phonon scattering, respectively. The values of the carrier concentration n and the mobility  $\mu$  are

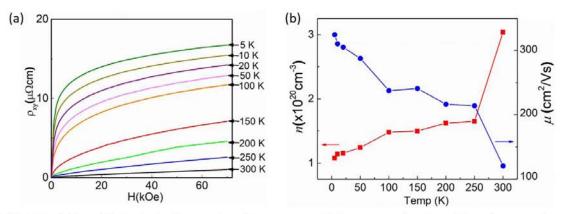


Fig. 4. (a) The Hall resistivity  $\rho_{xy}(H)$  of Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si measured at various temperatures. (b) The temperature dependence of the carrier concentration n and the mobility  $\mu$  of Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si.

respectively  $1.15 \times 10^{20} \, \text{cm}^{-3}$  and  $315 \, \text{cm}^2/(\text{V} \cdot \text{s})$  at 5 K. The carrier concentration in Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si ribbons is lower than those in Fe<sub>2</sub>TiSi thin films  $(5.5 \times 10^{20} \, \text{cm}^{-3})$  [13], bulk Fe<sub>2</sub>VAl  $(10^{21} \, \text{cm}^{-3})$  [33] and spin-gapless semiconductor Mn<sub>2</sub>CoAl films (10<sup>22</sup> cm<sup>-3</sup>) [22], but greater than those in HgCdTe (1015-1017 cm-3) [34] and bulk spingapless semiconductor Mn<sub>2</sub>CoAl (10<sup>17</sup> cm<sup>-3</sup>) [23]. The carrier mobility in our samples is much higher than that in Fe<sub>2</sub>TiSi thin films [13], CoFeCrAl films [30] and the Heusler spin-gapless semiconductor  $Mn_2CoAl$  [22,23], but comparable to the case of Si  $(1.4 \times 10^3 \text{ cm}^2/(\text{V}\cdot\text{s}))$ for electrons and  $4.5 \times 10^2 \, \text{cm}^2/(\text{V-s})$  for holes) [35]. Although the weak temperature dependence of resistivity, the almost linear nonconstant MR under high magnetic fields and the carrier concentration are similar to those of spin-gapless semiconductors, the variation in the temperature dependence of resistivity suggests an extrinsic semiconductor behavior. In general, the transport properties strongly suggest semiconducting behavior in the Fe<sub>2</sub>Ti<sub>0.5</sub>Co<sub>0.5</sub>Si compound.

#### 4. Conclusions

In summary, the structural, magnetic and transport properties of the  $Fe_2Ti_{0.5}Co_{0.5}Si$  Heusler compound are measured. The XRD analysis implies that the rapidly quenched  $Fe_2Ti_{0.5}Co_{0.5}Si$  ribbons crystallize mainly in the  $L2_1$  structure. This Heusler compound exhibits ferromagnetism, with the magnetization being 480 emu/cm $^3$  (2.36  $\mu_B/f.u.)$  at 5 K and a high Curie temperature of about 790 K. Transport measurements of  $Fe_2Ti_{0.5}Co_{0.5}Si$  show semiconducting behavior with a negative temperature coefficient of resistivity. Interestingly, the substitution of half the Ti atoms in the paramagnetic semiconducting  $Fe_2TiSi$  Heusler compound with Co atoms results in a ferromagnetic Heusler compound with semiconducting behavior. These results are expected to stimulate further research on thin films of similar compositions and potential applications in spintronic devices.

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